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Atty. Docket No. AMAT/5083/CMP/CMP/RKK

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Assistant Commissioner of Patents and Trademarks
Washington, D.C. 20231

Re: Inventor(s): YUCHUN WANG; RAJEEV BAJAJ; FRED C. REDEKER and SHIJIAN LI
Title: CHEMICAL MECHANICAL POLISHING COMPOSITION AND PROCESS

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 28 pages.
- ☒ Drawings totaling 2 pages, ☒ Formal ☐ Informal.
- ☒ Executed Declaration and Power of Attorney.
- ☐ Information Disclosure Statement w/ Form 1449 and References.
- ☒ Assignment of the invention to **Applied Materials, Inc.**
- ☒ Assignment Recordation Cover Sheet

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	32	-20=	12	x \$18.00	\$ 216.00
Independent Claims	4	-3=	1	x \$80.00	\$ 80.00
Basic Filing Fee				\$710.00	\$710.00
TOTAL FEES					\$1006.00

- ☒ The Commissioner is hereby authorized to charge \$1006.00 to Deposit Account No. **50-1074/5083/CMP/CMP/RKK**.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. **50-1074/5083/CMP/CMP/RKK**. A duplicate copy of this transmittal is enclosed.
- ☒ Please address all future correspondence to:

PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Express Mail Receipt No. EL684621498US

Date of Deposit 4/25/01

Signature Robert W. Mulcahy

Respectfully submitted,

Robert W. Mulcahy
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